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INFORMATION DISCLOSURE STATEMENT		Docket Number 10020/26301	
Application Number 10/810,853	Filing Date March 29, 2004	Examiner Not Yet Assigned	Art Unit 1762
Invention Title **METHOD AND APPARATUS FOR DEPOSITING MATERIALS WITH HIGH RESOLUTION**		Inventor(s) FORREST et al.	

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Date: 7/13/04

Signature: _____
Thomas F. Meagher (Reg. No. 29,831)

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

2. Since the U.S. Patent and Trademark Office has waived the requirement under 37 C.F.R. §1.98 (a)(2)(i) to submit a copy of each cited U.S. Patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003, copies of the U.S. patents and U.S. patent application publications listed on the modified PTO Form No. 1449 are **not** enclosed.

3. It is believed that no fees are due in connection with this Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

Dated: 7/13/04

By: _____
Thomas F. Meagher (Reg. No. 29,831)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	DOCKET NO. 10020/26301	SERIAL NO. 10/810,853
	APPLICANT FORREST et al.	
	FILING DATE March 29, 2004	GROUP Not Yet Assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE*
	6,596,443	July 22, 2003	Weaver et al.			
	6,214,631	April 1, 2001	Burrows et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

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EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	